

**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:  
**8070-1003**

Application No.:  
**NEW NONPROVISIONAL**

Sheet 1 of 1

Applicant:  
**Tatsuya SUZUKI et al.**

Filing Date:  
October 16, 2003

## Group Art Unit

**U.S. PATENT DOCUMENTS**

**FOREIGN PATENT DOCUMENTS**

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)  
"Ultra Clean ULSI Technology," 1995, BAIFUKAN, Tokyo, Japan

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)  
OHMI, Tadahiro. "Ultra Clean ULSI Technology," 1995, BAIFUKAN, Tokyo, Japan

EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

DATE: 3/9/2003

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\* Abstract provided for the Examiner's convenience

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V&T October 16, 2003